Ap	plication No.	Applicant(s)		
09/	928,663	SATO, KENJI	SATO, KENJI	
Notice of Allowability	aminer	Art Unit		
Qu	yen P. Leung	2828		
The MAILING DATE of this communication appears claims being allowable, PROSECUTION ON THE MERITS IS (OR ewith (or previously mailed), a Notice of Allowance (PTOL-85) or of TICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHT he Office or upon petition by the applicant. See 37 CFR 1.313 and	REMAINS) CLOSED in ther appropriate commi S. This application is	n this application. If not included unication will be mailed in due course.	THIS initiative	
\boxtimes This communication is responsive to <u>2/12/2004</u> .				
\boxtimes The allowed claim(s) is/are <u>2-13</u> .				
$\!$	miner.			
Acknowledgment is made of a claim for foreign priority under a a) □ All b) □ Some* c) □ None of the: 1. □ Certified copies of the priority documents have bee 2. □ Certified copies of the priority documents have bee 3. □ Copies of the certified copies of the priority documents International Bureau (PCT Rule 17.2(a)). * Certified copies not received: pplicant has THREE MONTHS FROM THE "MAILING DATE" of the oted below. Failure to timely comply will result in ABANDONMENT HIS THREE-MONTH PERIOD IS NOT EXTENDABLE. A SUBSTITUTE OATH OR DECLARATION must be submitted. INFORMAL PATENT APPLICATION (PTO-152) which gives reconstructed including changes required by the Notice of Draftsperson's 1) □ hereto or 2) □ to Paper No./Mail Date (b) □ including changes required by the attached Examiner's Amalendary Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(ceach sheet. Replacement sheet(s) should be labeled as such in the head of DEPOSIT OF and/or INFORMATION about the deposit of attached Examiner's comment regarding REQUIREMENT FOR	en received. en received in Application ents have been received is communication to file of this application. Note the attached EX ason(s) why the oath of submitted. Patent Drawing Review endment / Comment of the ader according to 37 CH of BIOLOGICAL MAT	on No In this national stage application from the areply complying with the requirement of the complying with the requirement of the drawings in the front (not the back) of the drawings in the submitted. Note the control of the control o	nts OF	
achment(s) Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview S Paper No. 7. ☐ Examiner's	formal Patent Application (PTO-152) ummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allowance Quyen P. Leung Primary Examiner Art Unit: 2828		

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REASONS FOR ALLOWANCE

- 1. In response to applicant's amendment filed 2/12/2004, claims 1,14 and 15 have been canceled. Claims 2-13 are pending.
- 2. The following is an examiner's statement of reasons for allowance: the cited prior art do not teach or fairly suggest a semiconductor laser comprising a diffraction grating having a normalized coupling coefficient kL of at least 2.0 and the active layer has a gain that saturates as a carrier concentration in the active layer increases.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quyen P. Leung whose telephone number is (571)272-1943. The examiner can normally be reached on 9-5:30, M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on (571)272-1834. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Quyen P. Leung Primary Examiner Art Unit 2828

QPL